

Notice of References Cited	Application/Control No. 10/591,976		Applicant(s)/Patent Under Reexamination ROSSMANN ET AL.	
	Examiner KENNETH J. WHITTINGTON		Art Unit 2858	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,969,988	11-2005	Kakuta et al.	324/207.25
*	B	US-4,752,733	06-1988	Petr et al.	324/225
	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Demierre, Michel, IMPROVEMENTS OF CMOS HALL MICROSYSTEMS AND APPLICATIONS FOR ABSOLUTE ANGULAR POSITION MEASUREMENTS, University These for Institute of Microelectronics and Microsystems, dated September 2003.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.